

**PREPARATION AND PHYSICAL CHARACTERIZATION OF NANO
POROUS SILICON TO TAKE ADVANTAGE OF IT IN SOME
ENVIRONMENTAL APPLICATIONS**

Submitted By

Hager Abd El Hakim Mohamed Nawar

B.Sc. of Science (Physics), Faculty of Science, Ain Shams University, 2008

A thesis submitted in Partial Fulfillment
Of
The Requirement for the Master Degree
In
Environmental Science

Department of Environmental Basic Sciences
Institute of Environmental Studies and Research
Ain Shams University

2014

APPROVAL SHEET

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List of abbreviations

LIST OF ABBREVIATIONS

FWHM	Full width at half maximum
XRD	X ray diffraction
PSi	Porous silicon
FTIR	Fourier transforms infrared
SEM	Scan electron microscope
TEM	Transmission electron microscope
TOF-SIMS	Time-of-Flight Secondary Ion Mass Spectrometry
HF	Hydrofluoric acid
PL	Photoluminescence

List of abbreviations

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